

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778	Examiner: Allan W. Olsen
Confirmation No: 6490	Attorney Docket No: 2077 USA D01/ETCH/SILICON/JB1
Filed: June 16, 2000	
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	February 19, 2008 San Francisco, California

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

VIA ELECTRONIC TRANSMISSION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This communication is in response to the Office Action mailed on September 19, 2007, and is being timely filed with a two-month extension of time.

Certificate of Transmission

I hereby certify that this correspondence is being electronically filed with the U.S. Patent Office, for the attention of the Commissioner for Patents, on the date shown below.

By Leslie Mills Date February 19, 2008